



IFW

PATENT  
Attorney Docket No. 4632-64

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Kyoichi Iwata ) Group Art Unit: 2125  
Application No.: 10/525,741 ) Examiner: Michael D. Masinick  
Filed: February 28, 2005 )  
For: Dent Distribution Diagram Drawing ) Confirmation No.: 8293  
Method and System in Shotblasting, and )  
Processing Conditions Setting Method )  
and Shotblasting Device )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REPLY TO OFFICE ACTION**

In reply to the Office Action mailed September 1, 2006, please amend the  
above-identified application as follows:

**Amendments to the Specification** are included in this paper.

**Amendments to the Claims** are reflected in the listing of claims in this paper.

**Remarks/Arguments** follow the amendment sections of this paper.